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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Eiju KOMURO et al.

Group Art Unit : 2812

Appl. No. : 10/811,812

Examiner : Not Yet Assigned

Filed : March 30, 2004

Confirmation No. : 2851

For : METHOD OF MANUFACTURING A PIEZOELECTRIC THIN FILM RESONATOR, MANUFACTURING APPARATUS FOR A PIEZOELECTRIC THIN FILM RESONATOR, PIEZOELECTRIC THIN FILM RESONATOR, AND ELECTRONIC COMPONENT

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop AMENDMENT  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir :

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98 and supplemental to the Information Disclosure Statements filed on August 3, 2004 and June 30, 2004, Applicants hereby submit a copy of a Notice of Reasons for Rejection from the Japanese Patent Office, with respect to patent family member Japanese Patent Application No. JP 2003-94569, in which the following documents were cited:

- (1) Japanese Laid-Open Patent Publication No. HEI 10-126160, together with patent family member U.S. Patent No. 5,714,917. Applicants note that the Japanese document was previously cited on the Information Disclosure Statement on August 3, 2004;

(2) Japanese Laid-Open Patent Publication No. 2002-335141, together with patent family member U.S. Patent No. 6,617,249. Applicants note that the Japanese document was previously cited on the Information Disclosure Statement on August 3, 2004;

(3) Japanese Laid-Open Patent Publication No. 2002-344280. Applicants note that the Japanese document was previously cited on the Information Disclosure Statement on August 3, 2004; and

(4) Japanese Laid-Open Patent Publication No. 2001-77013, which was published on November 22, 2002, together with an English language Abstract of the same, an English language translation of selected portions of the same, and patent family member U.S. Patent No. 6,812,473.

Further to 37 C.F.R. §1.98 (a)(2)(ii), copies of the U.S. patents are not enclosed herewith. However, if any copies are needed, the Examiner is respectfully requested to contact the undersigned.

Applicants respectfully request that the Examiner consider the above material and cite the same. A copy of the document (4) is attached hereto and all of the documents are listed on the attached PTO-1449 Form. The Examiner is requested to initial the appropriate spaces on the attached Form and to return a copy of the completed Form to the Applicants with the next official communication in the present application.

Applicants note that an Office Action on the merits has not issued in the present application, and thus no fee is believed necessary to ensure consideration of the submitted material. However, if an Office Action on the

merits has issued and is crossing this statement in the mail, Applicant will certify that the document (4) in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement, and thus no fee is required to ensure consideration of the submitted material.

Applicants additionally note that documents (1)-(3) were previously cited in an Information Disclosure Statement and thus no fee or certification is required to ensure consideration of these documents, as it was already considered.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,  
Eiju KOMURO et al.

  
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